



Technologies and Nanotechnologies of Magnetic-Abrasive Machining of Surfaces

Speaker:

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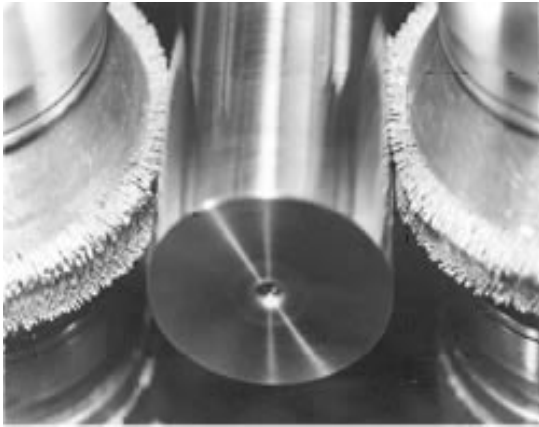
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www.polimag.eu

Minsk 2021

Method

- The magnetic field transforms the ferroabrasive powder into a kind of an "elastic brush" and polishes the surface

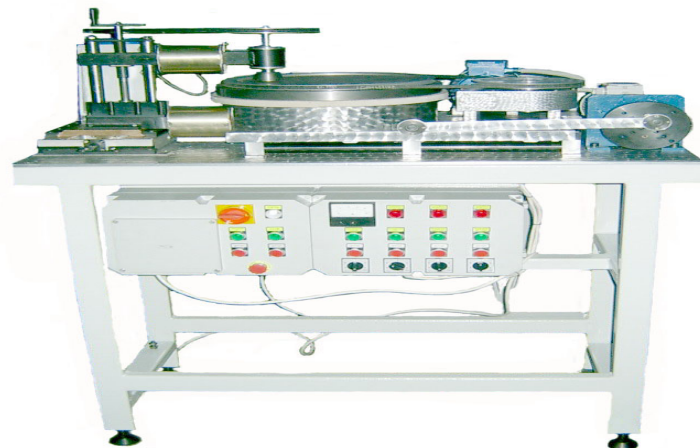
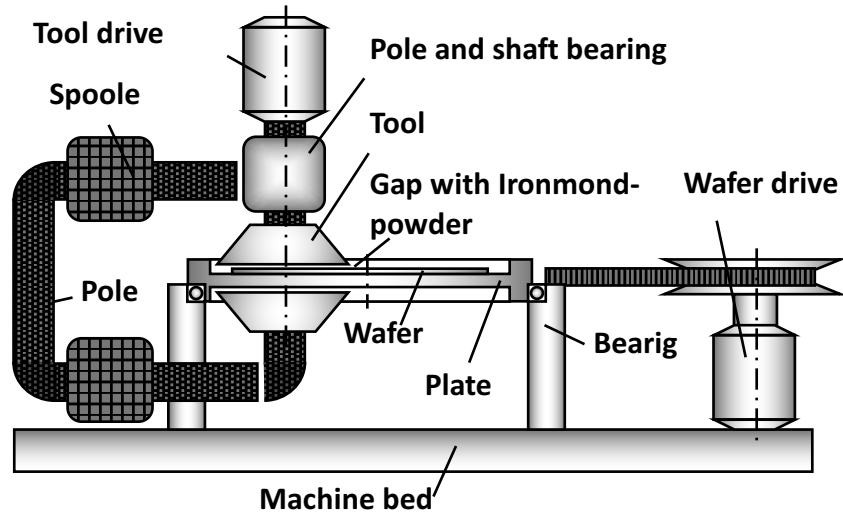


- Pulsing magnetic field improves the structure of the preface layer of the material

Application

- Formation of surface nanorelief
- Polishing surfaces before coating
- Cleansing surfaces before welding
- Polishing surfaces to increase resistance to corrosion, wear and mechanical destruction
- Surface modification under physical-chemical processes (diffusion, adhesion, etc.)

Experimental model for polishing plate surfaces



Polishing of electronics: Si-wafers

Ra = 0.72 nm

TTV = 2.9 μm



Mag: 49.9 X

Mode: PSI

Surface Data

Surface Statistics:

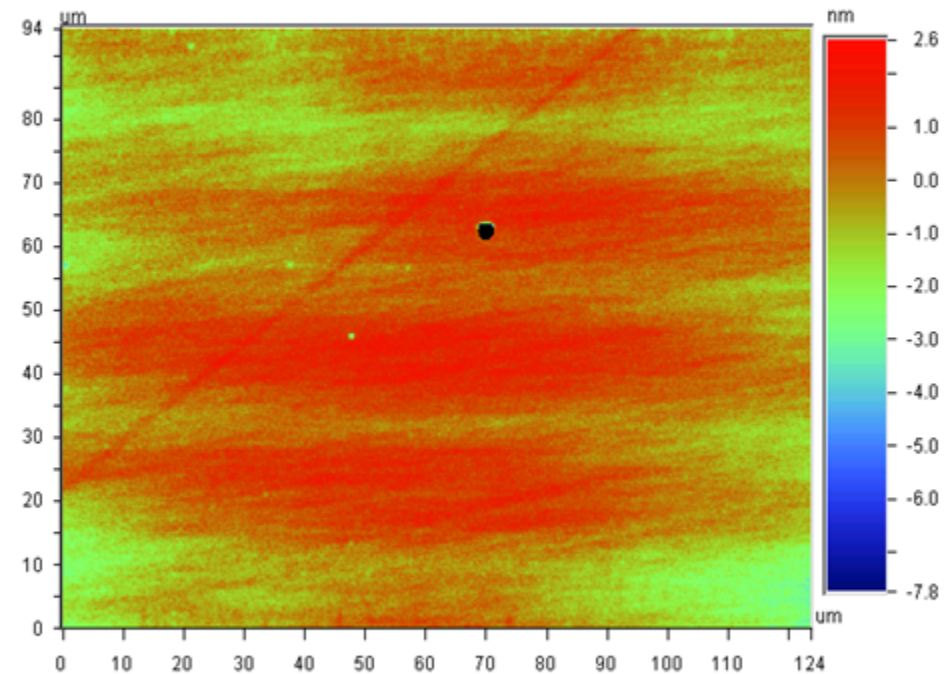
Ra: 0.72 nm
Rq: 0.89 nm
Rz: 6.77 nm
Rt: 10.39 nm

Set-up Parameters:

Size: 736 X 480
Sampling: 168.48 nm

Processed Options:

Terms Removed:
Tilt
Filtering:
None



Title: Si No.1

Note: 2nd measurement

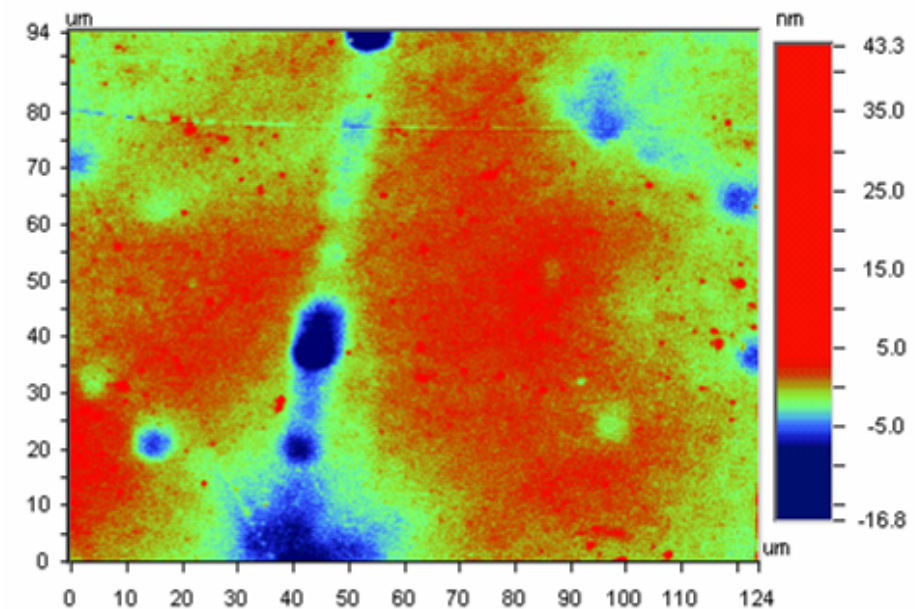
Polishing laser crystals (CaF₂ and other)

Ra = 1.537 nm



Contour Plot

Measurement Parameters	
File:	CaF2-Rand
Wavelength	605.40 nm
Wedge	0.50
X/Y Size	736 X 480
Pixel size	168.48 nm
Date	04/10/2003
Time	08:39:40
Averages	1
Analysis Results	
Ra	1.537 nm
Rms	2.126 nm
20 Pt. PV	41.879 nm
2 Pt. PV	60.19 nm
Analysis Parameters	
Terms	Tilt
Masks:	
Filtering	None
Data Restore	No
Valid Points	353280

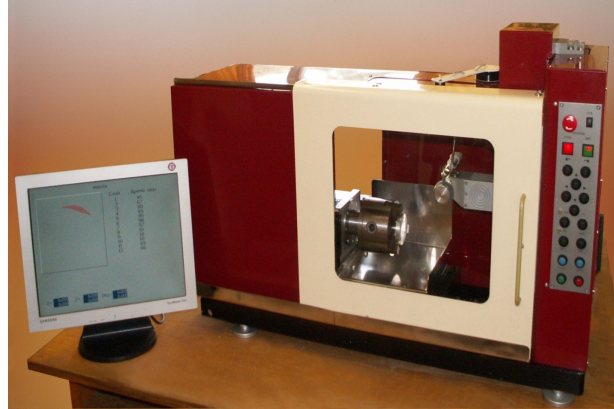


Title: CaF2-Rand
Note: Nr.3

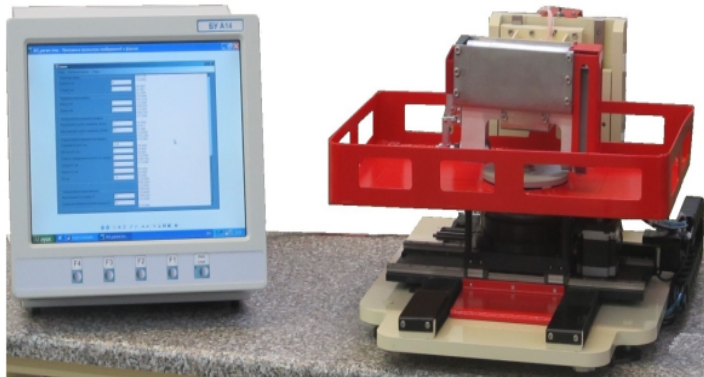
Equipment for Superfine polishing



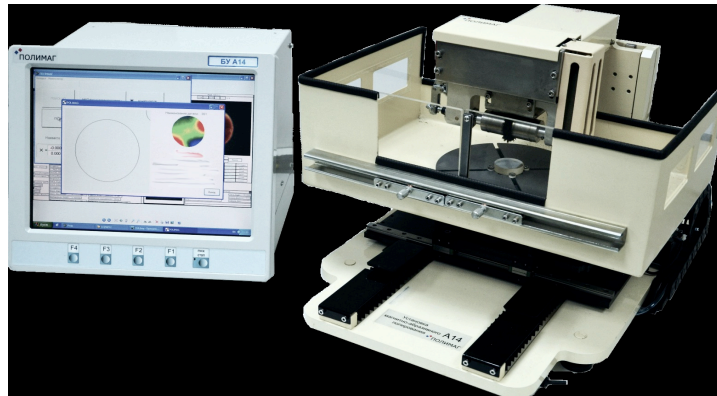
3905
Valid layout



A09
Experimental
sample



A14
Experimental
sample



A17
Industrial
plant

Features of superfine polishing

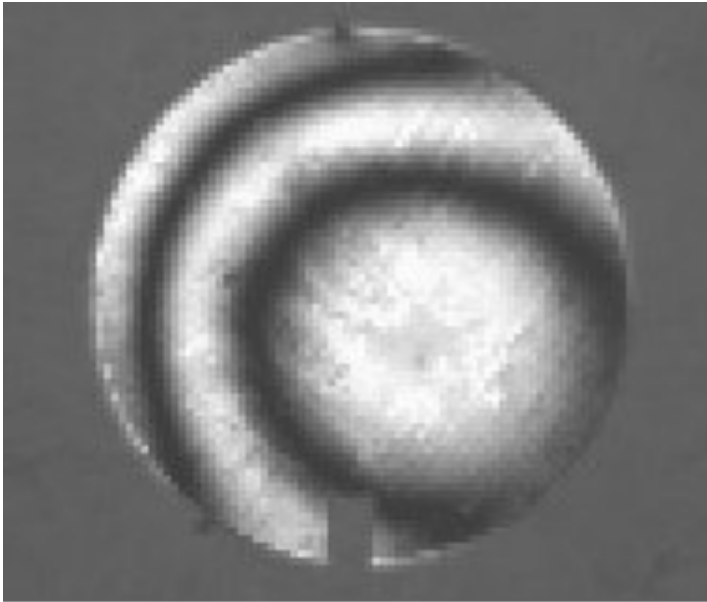
Application: surfaces of high-precision details of optics, lasers, micro- and nanoelectronics, etc.

Benefits:

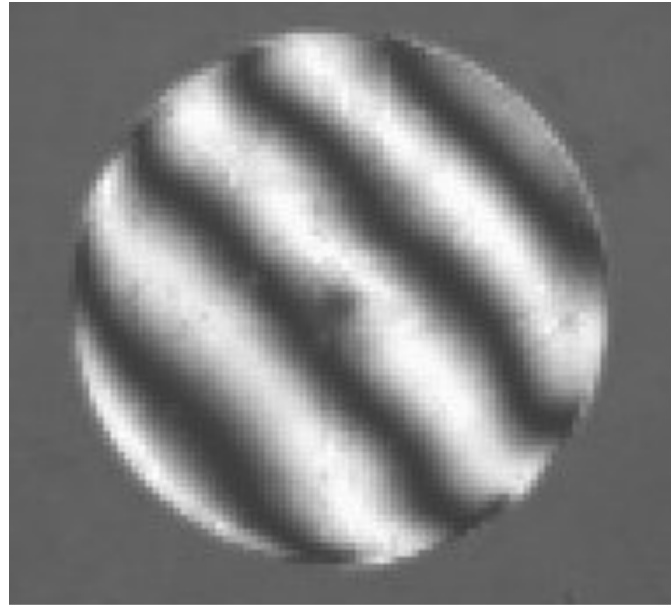
- Very high quality
 - Roughness, Ra:
 - before: 8 – 10 nm
 - after: 0.2 – 0.8 nm
 - minimum defects in the structure of the surface layer
- Performance is 4-10 times higher than that of other technologies
- Cost is 3 - 5 times lower than cost of other technologies
- Environmental friendliness

Optical glass polishing

Interferograms of optical glass before and after MAM



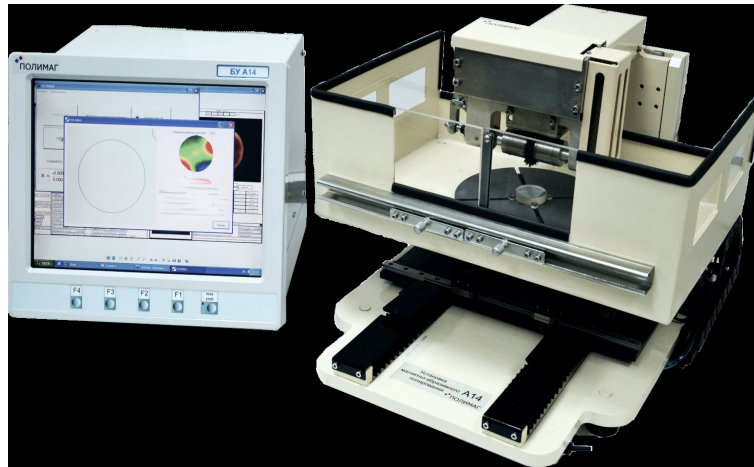
Before MAM: **PV = 158 nm**
Ra = 20 nm



After MAM: **PV = 30 nm**
Ra = 1.4 nm

Magnetic-Abrasive Polishing of plain, spherical and aspherical surfaces

Model A17



Before MAM

Sa **0.27 nm**

Sq 0.369 nm

Sp 4.58 nm

Sv 3.66 nm

After MAM

Sa **0.14 nm**

Sq 0.189 nm

Sp 1.13 nm

Sv 0.735 nm

Technical characteristics

Piece diameter 10 - 200 mm

Ra of the polished surface 0.2 – 0,8 nm

Polishing time 2 - 15 min

Power consumption 1.5 kW

Size L×W×H 900 × 500 × 500 mm

Weight 80 kg

ISO 25178

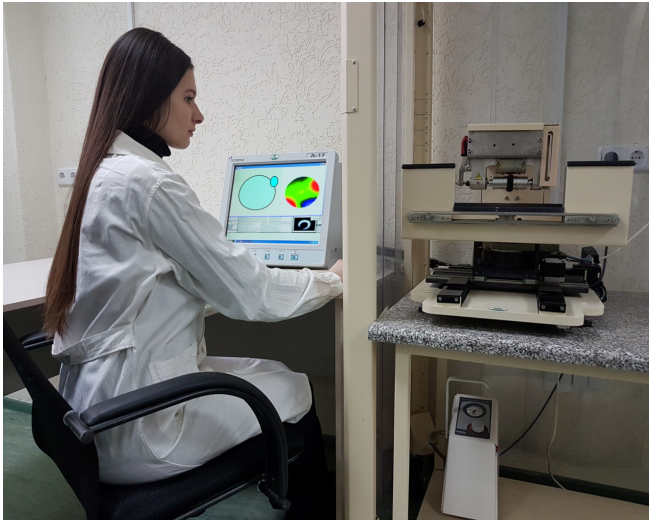
MAM potential

MRF (Q22-XE) Q-flex 100



Analogs

Model A17

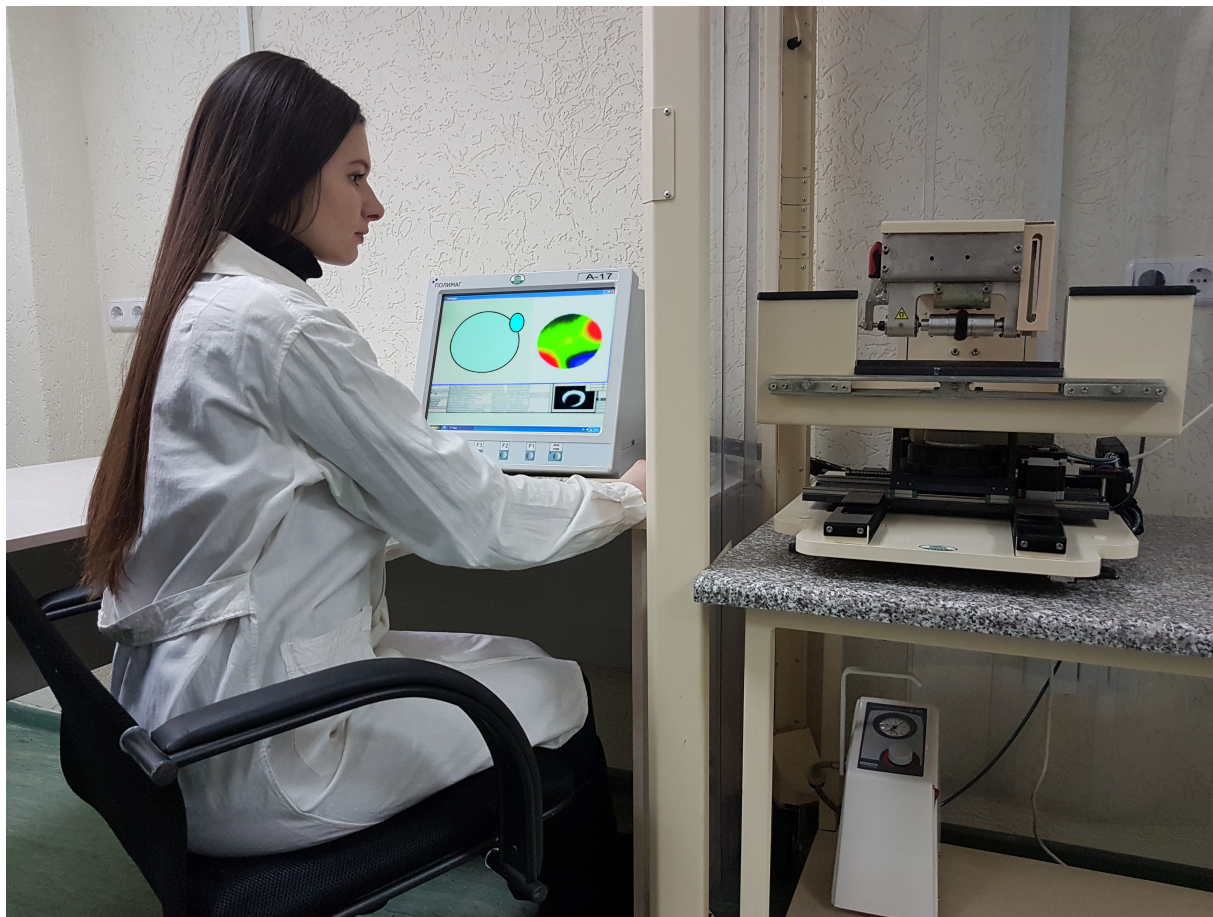


Before MAM After MAM

Sa	0.27 nm	Sa	0.14 nm
Sq	0.369 nm	Sq	0.189 nm
Sp	4.58 nm	Sp	1.13 nm
Sv	3.66 nm	Sv	0.735 nm
Sz	8.24 nm	Sz	1.87 nm

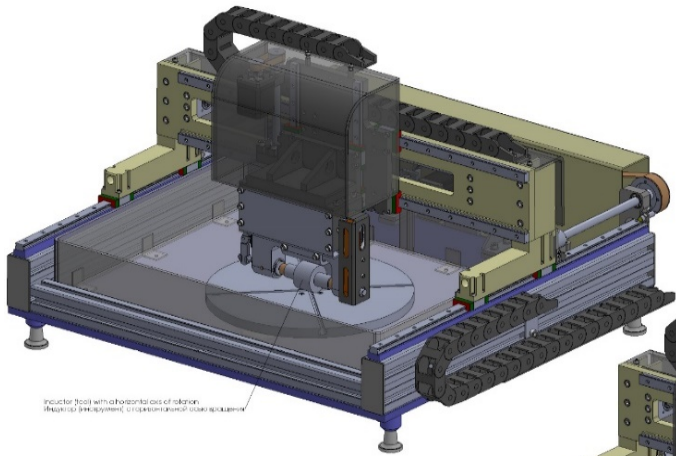
ISO 25178

Model A17



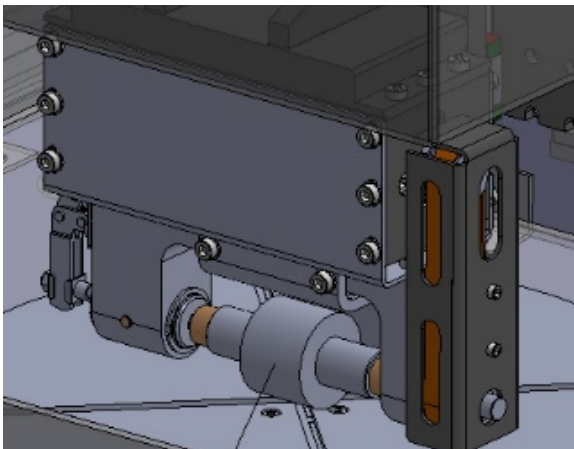
A17 in the autonomous
clean zone

Model A20-300 with horizontal axis



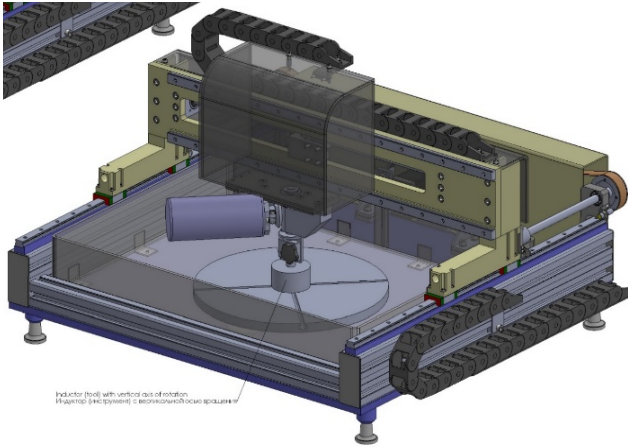
Horizontal axis of rotation of the inductor-tool

- carries out polishing (according to the digitized interferogram of the original surface) with the periphery of the brush ring formed by a magnetic field from a ferro-abrasive powder
- contact area of the powder with the polished surface is about 1 cm²
- provides nanorelief with $R_a < 3 \text{ nm}$
- shape parameter $PV < 30 \text{ nm}$



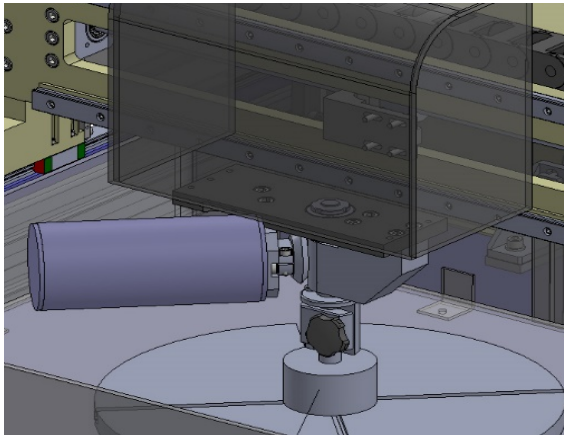
This pattern can be used to polish flat, spherical and aspherical surfaces. In some cases, complex surfaces can be polished.

Model A20-300 with vertical axis



Vertical axis of rotation of the inductor-tool

- implements the MAC with the end of the brush ring (by analogy with face milling)
- contact area 50 cm²
- provides $R_a < 3$ nm
- shape parameter $PV < 30$ nm
- improves surface shape characteristics by 30-50%



This scheme can be used to polish flat and closed surfaces.

Change from one layout to another is less than 15 minutes.

Laser induced damage threshold



LEADIS LTD
Sculpture Avenue 10,
11 Trenchard Way, Luton, LU1 3BH

Company: 01582 3001 3002
Mobile: 07902 225 225
Email: info@leadis.co.uk
Web: www.leadis.co.uk

1. Book a 120 second Laser
induced damage threshold
test - 10 minutes

2. www.leadis.co.uk

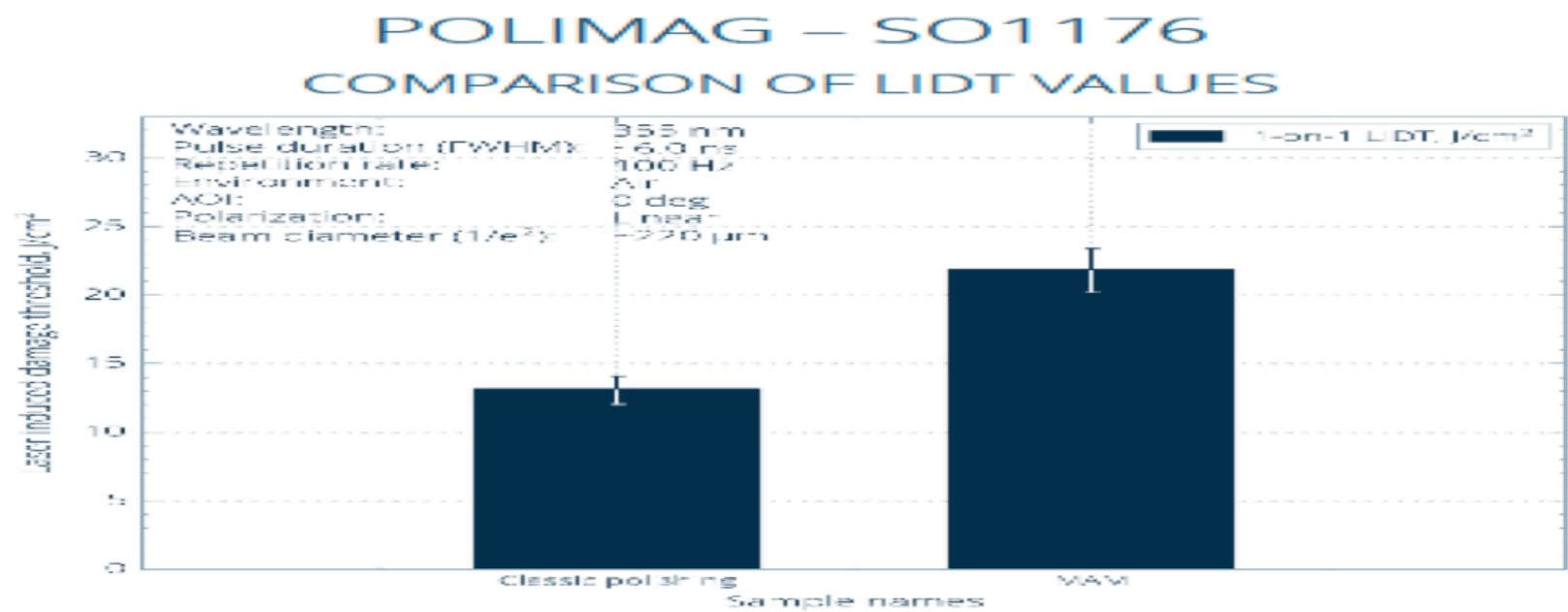
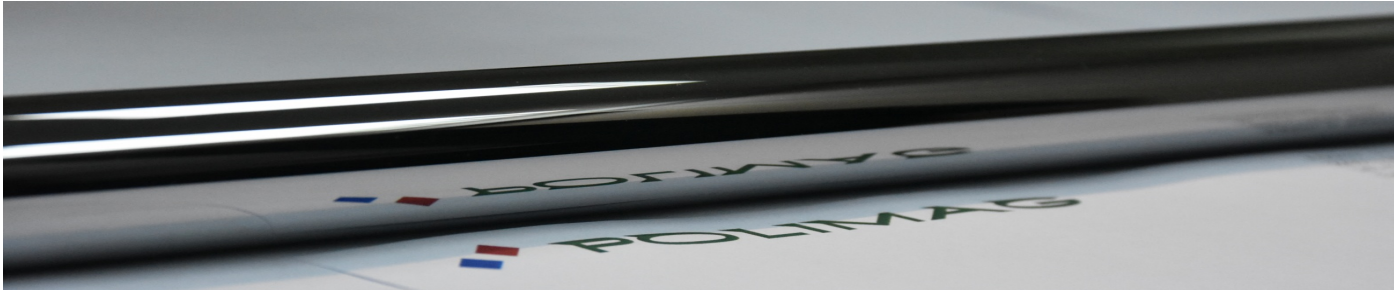


Figure 1: Comparison of SO1176 measurements.

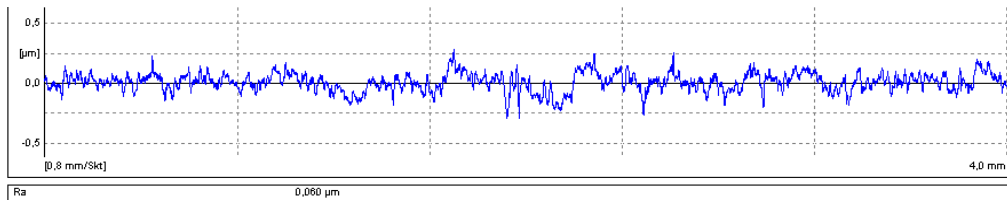
Table 1: SO1176 data spreadsheet

Sample	Threshold (1-on-1)	Error lower	Error upper
MAM	21.80	1.58	1.58
Classic polishing	13.13	1.07	0.96

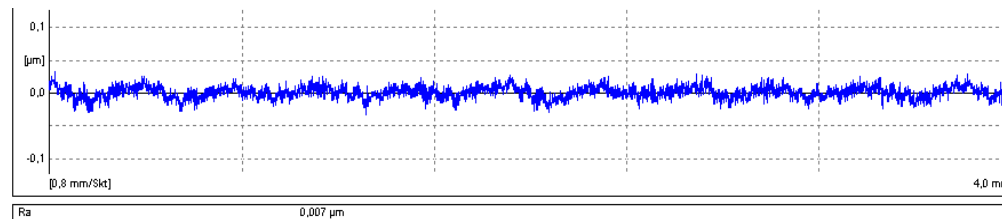
Magnetic-abrasive polishing of stab WC-Co



Cylindrical sample (D x L = 22 x 280 mm), of WC - Co alloy



Before MAP: Ra = 53 nm



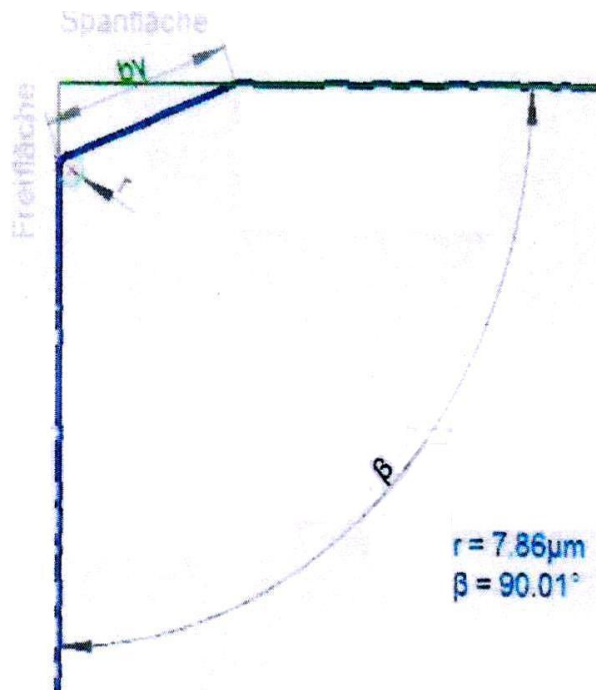
After MAP: Ra = 7 nm

Ra measurements

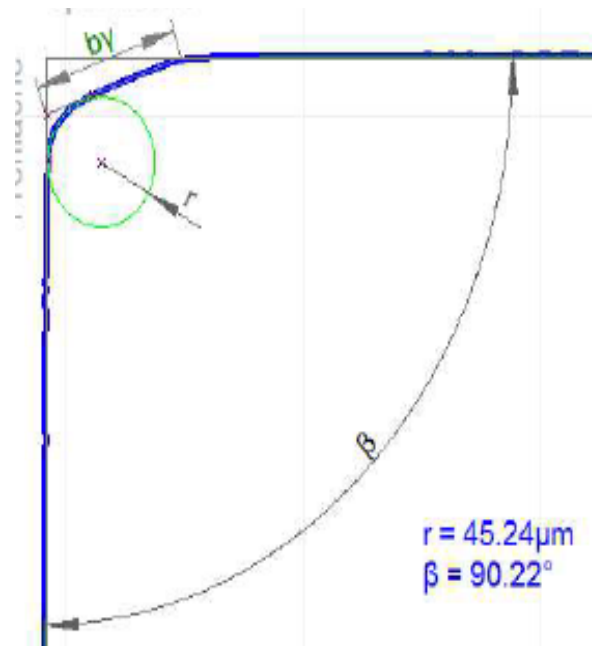
	before MAP	after MAP
1	56	7
2	48	7
3	52	7
4	60	8
5	47	7
Mean	53	7

Polishing ceramics: plates for cutters and mills

Before MAM
 $r = 7.86 \mu\text{m}$

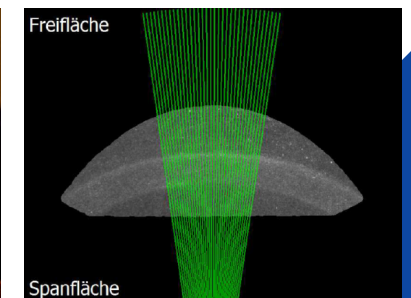


After MAM
 $r = 45.24 \mu\text{m}$

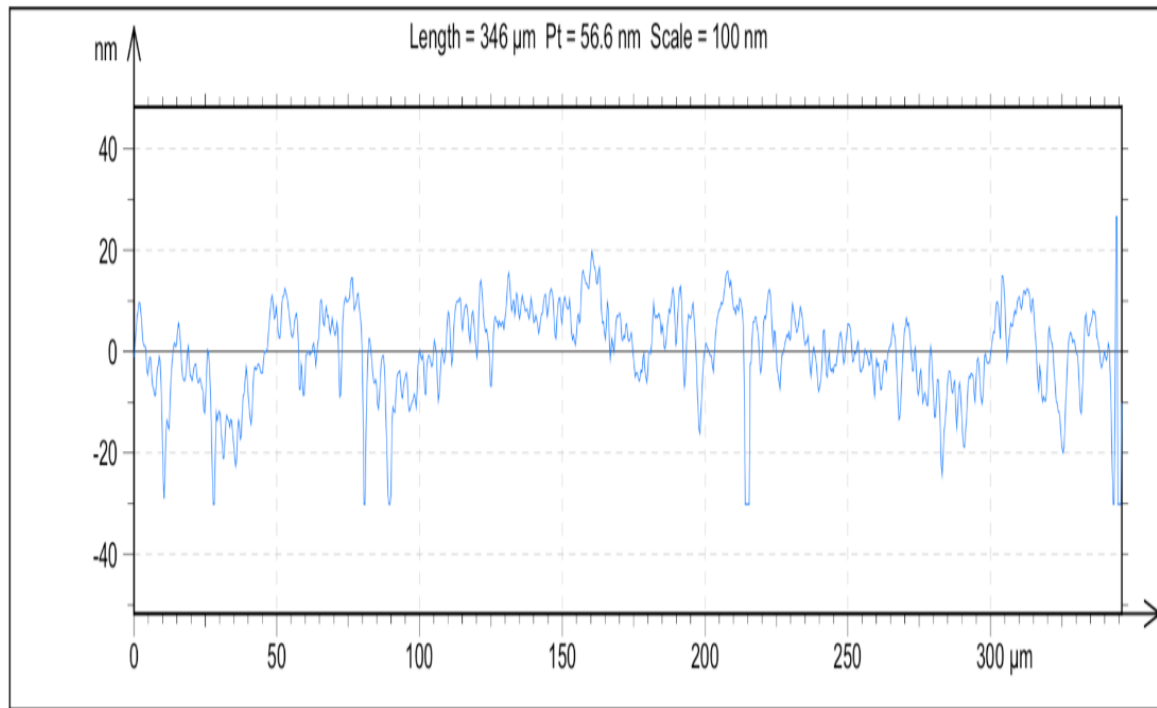


Vandurit GmbH, Germany

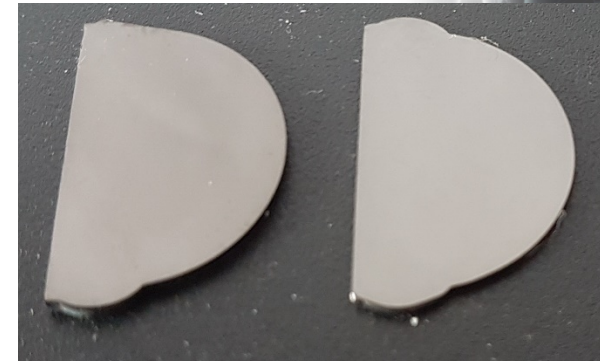
Materials	Microhardness, GPa
Diamond	100
Borazon	88
SiC	33
Al_2O_3	20
Si	12



MAP artificial heart valve: valve surface



Sash material (locking elements):
pyrolytic carbon (sitall)



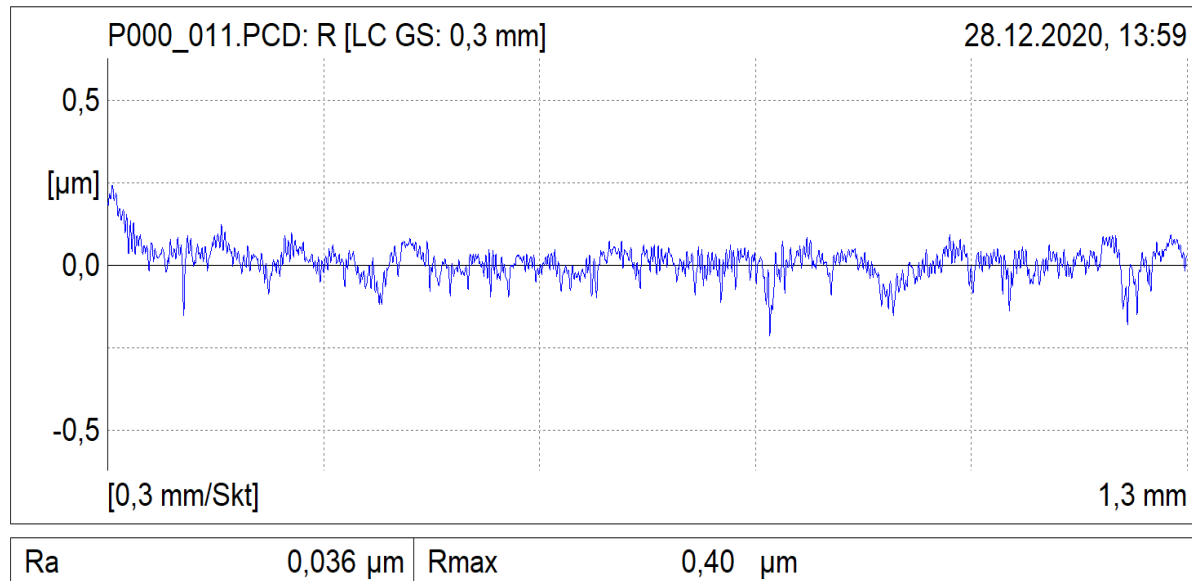
After MAM

Ra **3.91 nm**

Rz **24.39 nm**

Sq **9.41 nm**

MAP artificial heart valve: stent surface



Stent material: Ni - Ti alloy



After MAM

Ra 36 nm

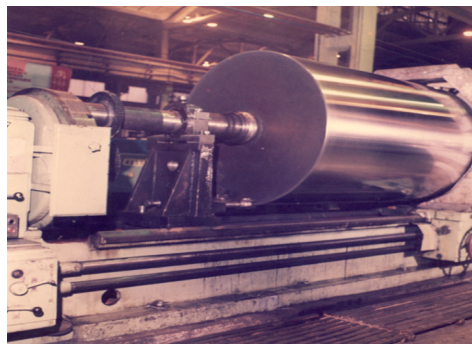
Comparison of MAM and MRF

	MRF (QED, USA)	MAM (Polimag, Belarus)
Technological characteristics		
intensity (capacity) %	100	200-500
roughness Ra, nm	< 1	< 1
technological tool	magnetoreological fluid	ferroabrasive powder
Technical characteristics		
complexity of process, maintenance and operation	high	medium
electricity consumption, kWt	3	2
annual consumption of technological tool	100 liters	20 kg
Cost		
cost per unit, \$	500	200
annual cost, \$	50 000	4 000

MAM equipment (polishing and cleansing) produced in 1975 – 1995



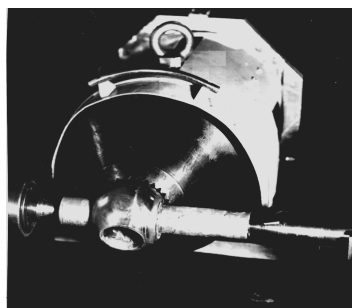
Cleansing edges
before welding



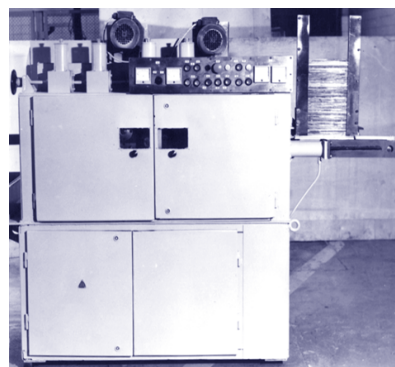
Polishing shafts



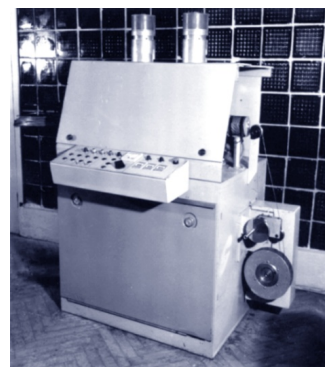
Polishing screws



Polishing spheres



Polishing and
cleansing pipes

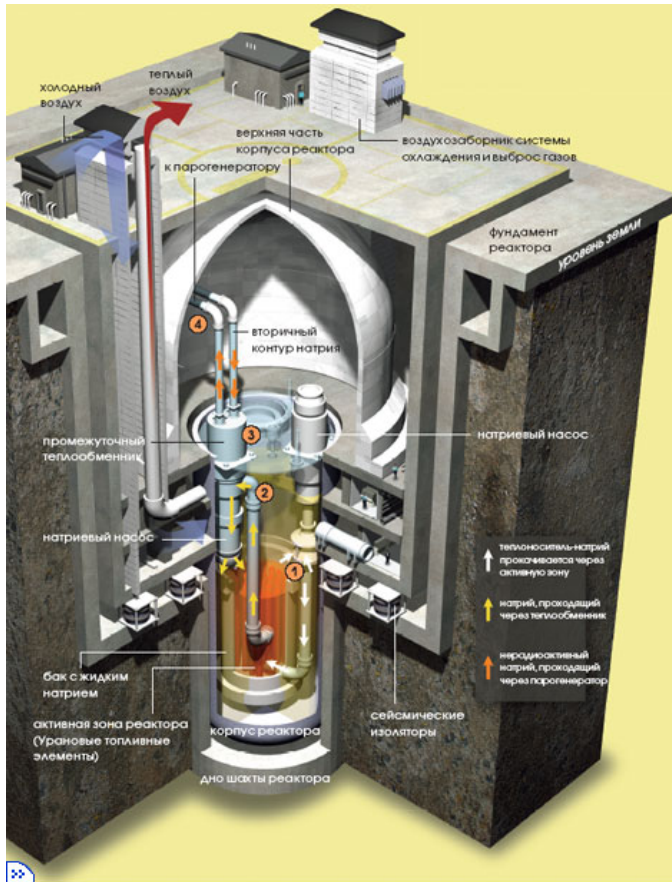


Cleansing wire

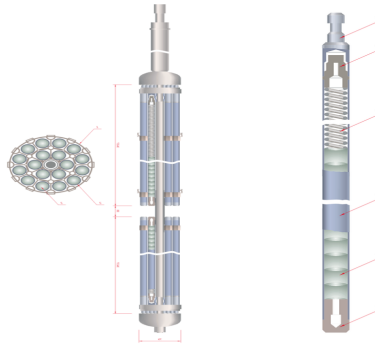


Cleansing plates
and bands

Magnetic abrasive polishing of fuel rods of nuclear reactors



Nuclear reactor scheme



Heat-releasing element (fuel rod)



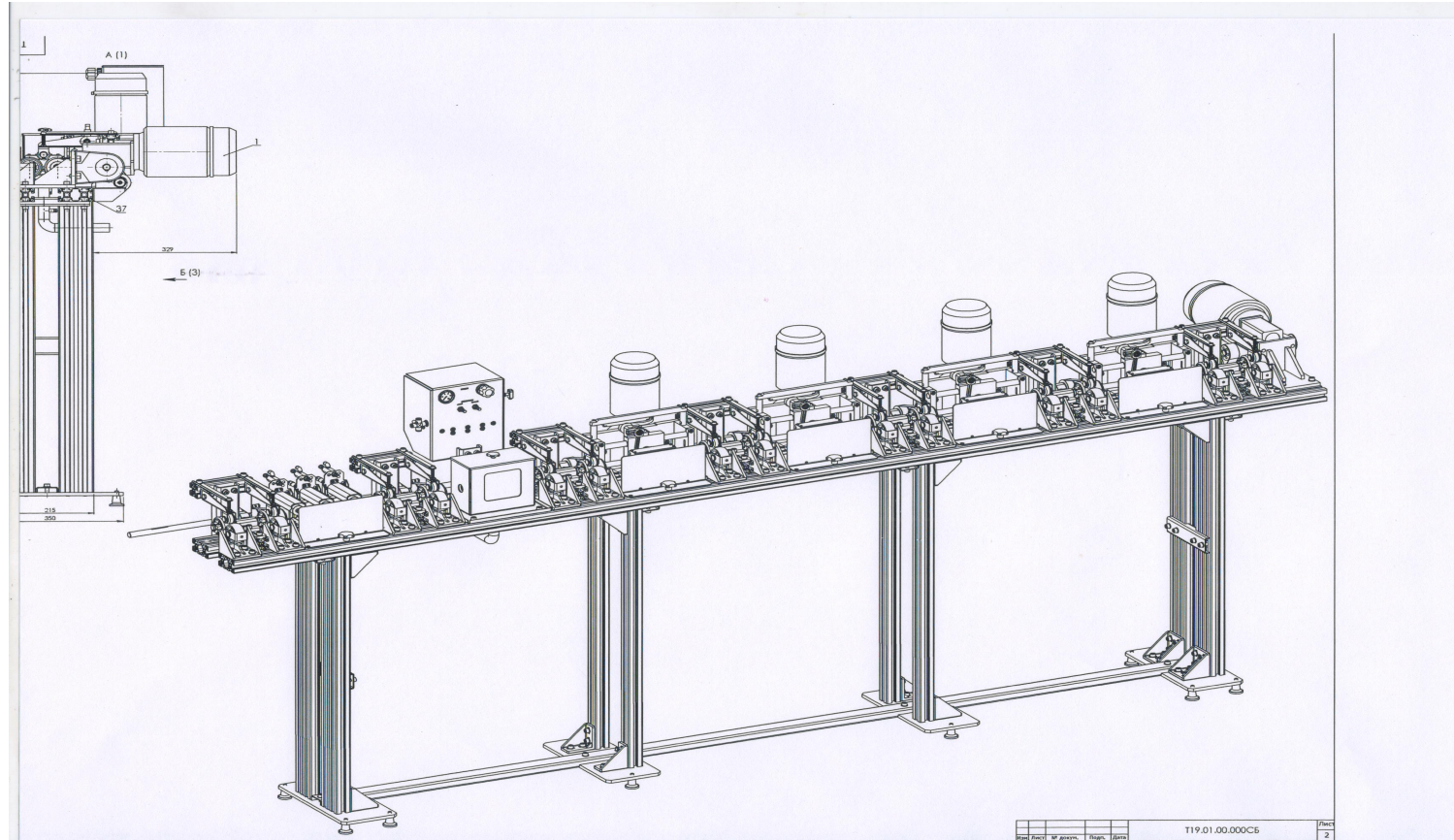
Fuel cell assembly



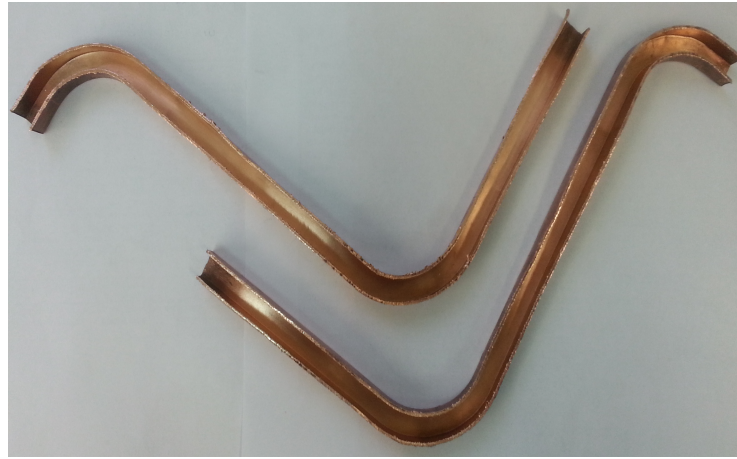
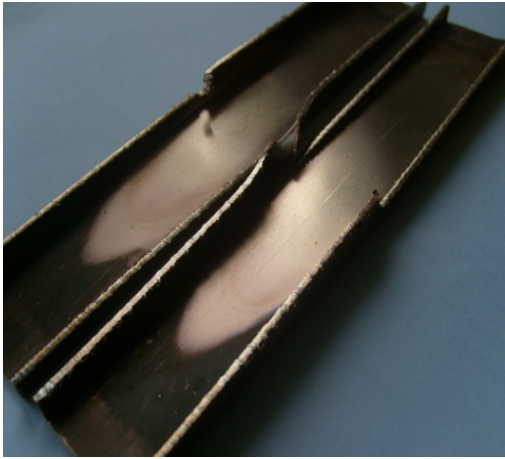
Model T15 for polishing of pipes fuel rods

Conventional technologies (chemical etching, grinding and mechanical polishing) do not provide the required surface quality of pipes

Working module of plant T19



MAP of the inner surfaces of the waveguides

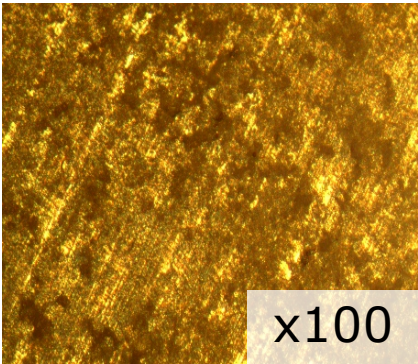


Waveguide material: alloys Cu, Al and Si, steel, etc.

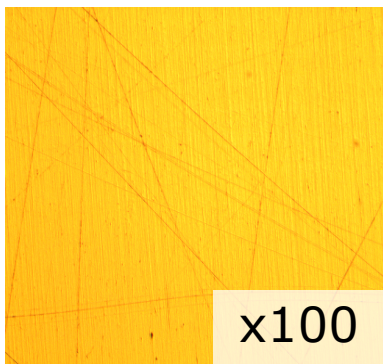
Before MAP 0.800 μm

After MAP 0.076 μm

Flat punch surface



x100



x100



Roughness Ra, μm

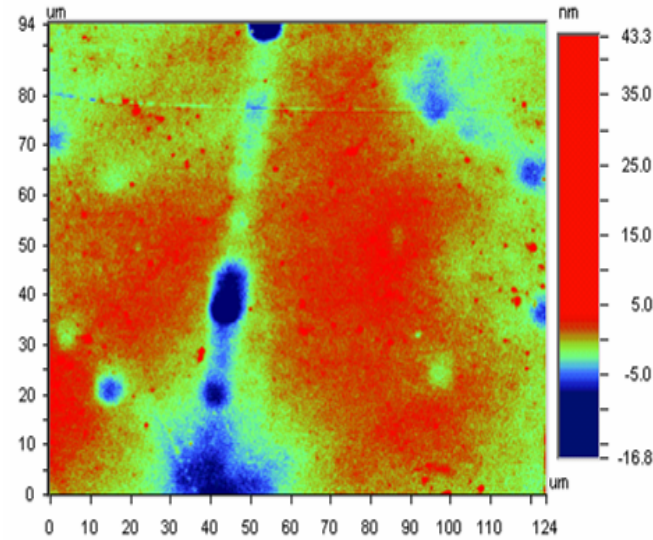
	Before MAP	After MAP	
		20 passes	30 passes
1	2.897	0.328	0.024
2	2.761	0.413	0.021
3	2.555	0.382	0.029
4	2.671	0.384	0.040
5	2.437	0.685	0.040
6	2.634	0.623	0.034
7	2.666	0.449	0.026
8	2.664	0.325	0.038
9	2.660	0.279	0.098
10	2.788	0.510	0.052

Examples of details for MAM



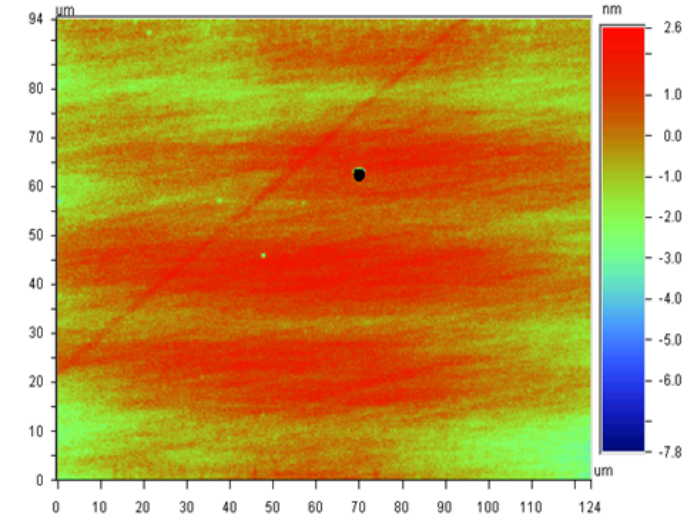
Optics

Ra = 0,14 nm = 1,4 Å



Laser ceramics

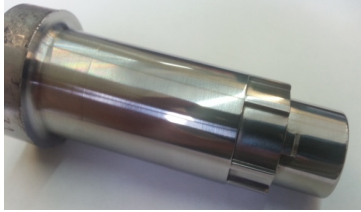
Ra = 1.537 nm



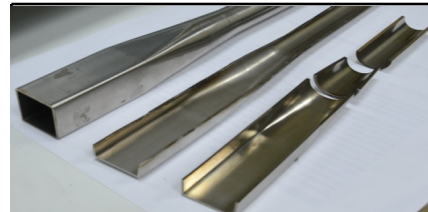
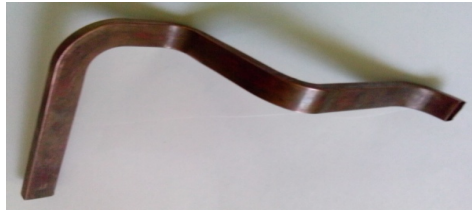
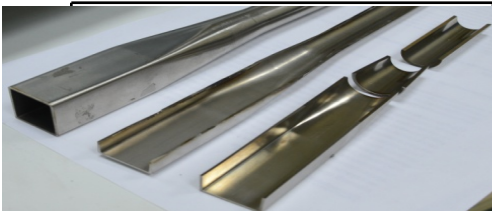
Si-wafers for electronics

Ra = 0.72 nm

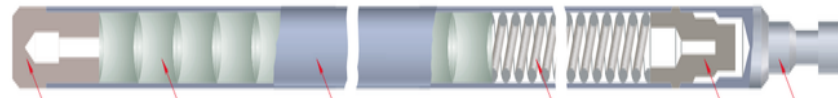
Examples of details for MAM



Tools:
cutters, punch, drills

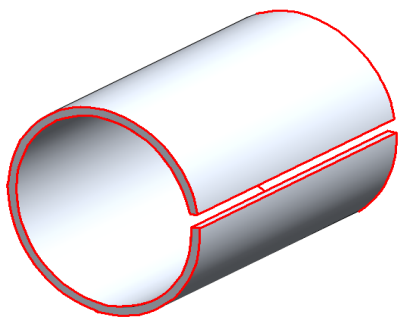


Pipes:
external and internal
surfaces

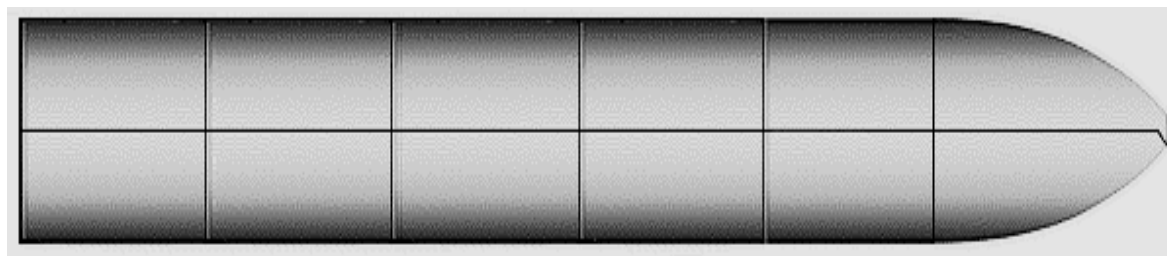


Envelopes of fuel rods
of nuclear reactors

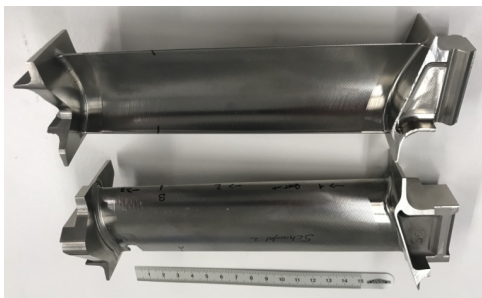
Examples of details for MAM



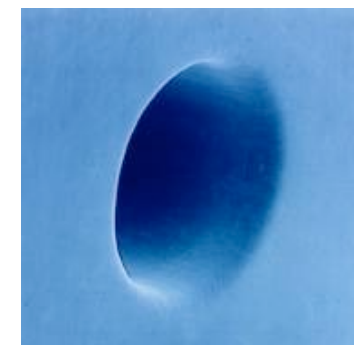
Cleansing edges
before welding



Cleansing of surfaces of details
for aviation, space, ship and
other industries

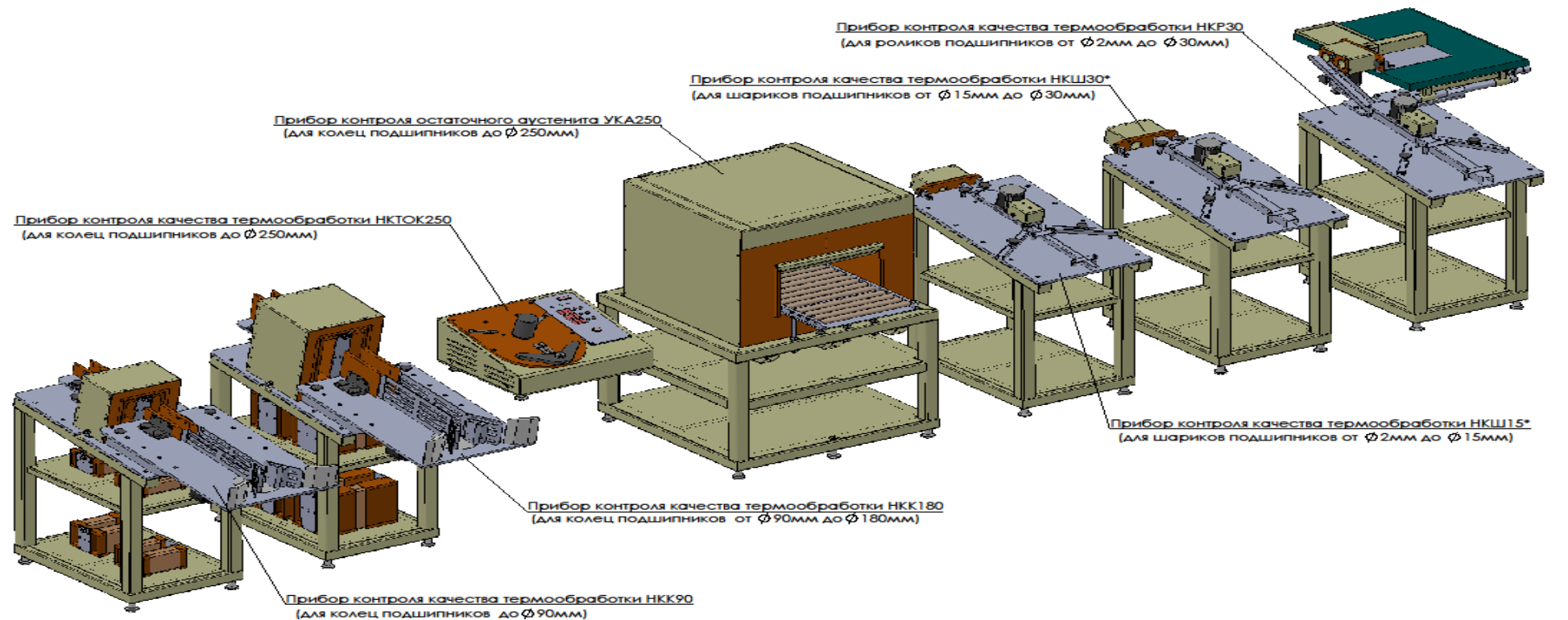


Polishing
aviaturbine blades



Removing burrs and edges rounding

Instruments for quality control of bearing components after heat treatment



Все приборы изображены без электронных блоков управления
*Приборы изображены без устройств автоматической поштучной подачи шариков

Publications

More than 170 scientific publications

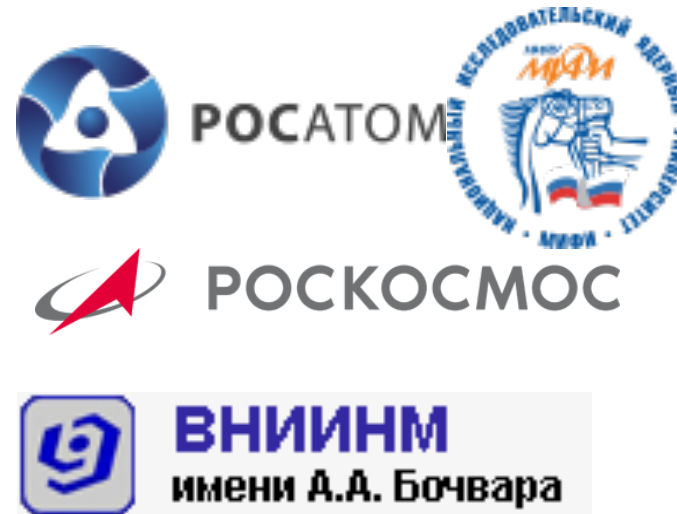
More than 70 patents

Partners

China



Russia



Germany



South Korea



Italy

University of Ferrara





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